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ARTICLE

# Microstructure and Mechanical Properties of Ti(Cr)SiC(O)N Coatings Deposited by Plasma Enhanced Magnetron Sputtering

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Abstract: TiSiCN, TiCrSiCN, TiCrSiCN, TiCrSiCON, CrSiCN and CrSiCON coatings have been deposited on WC-Co substrates and Si wafers using plasma enhanced magnetron sputtering (PEMS) technique. The microstructure, composition and mechanical properties of the non-oxygen coatings and oxygen-containing coatings were studied by XRD, SEM, EDS and load-depth-sensing indentation. The tribological behavior of the coatings against Al<sub>2</sub>O<sub>3</sub> balls was conducted by pin-on-disc tests. The results show that TiSiCON, TiCrSiCON and CrSiCON coatings exhibit the face center cubic (fcc) TiN-type (or CrN-type) structure. The existence of oxygen will induce loose structure and more defects for TiSiCON, TiCrSiCON and CrSiCON coatings compared with TiSiCN, TiCrSiCN and CrSiCN, respectively. The addition of oxygen element would lead to the decrease of the hardness (*H*) and elasticity of Ti(Cr)SiCN coatings. TiCrSiCON and CrSiCON coatings without oxygen, respectively. The TiSiCON with higher friction coefficient and wear rate shows poor abrasive wear resistance than TiSiCN.

Key words: Ti(Cr)SiC(O)N; oxygen-containing coatings; microstructure; wear; mechanical properties

Nanocomposite TiSiN coatings show many improved properties, such as high hardness, excellent oxidation resistance (up to 800 °C), high temperature stability (up to 1000 °C) and wear resistance in comparison with conventional TiN and TiC coatings due to the unique microstructure with nano-sized TiN crystallites embedded in amorphous  $Si_3N_4$ matrix<sup>[1-3]</sup>. Based on this prototype of TiSiN, other transition metals (such as Cr, Ti, W, V) can also form Me-Si-N (Me refer to transition metal) coatings with the nanocomposite microstructure and excellent mechanical properties <sup>[4,5]</sup>. Because of these promising properties, the industrial applications of Me-Si-N nanocomposite coatings on machining, stamping and forming tools have been concerned by researchers and companies and these have acquired encouraging progress<sup>[6,7]</sup>. The structure and properties of Me-Si-N nanocomposite coatings are affected by the element composition and the fraction. The content of Si element in Me-Si-N nanocomposite coatings will affect the properties of the coatings. The Si element can exist in solid solutions<sup>[8]</sup> and amorphous Si<sub>3</sub>N<sub>4</sub> phase<sup>[9]</sup>, even free Si when the Si content above 17 at%<sup>[10]</sup>. Generally, when the Si content reach 3 at%~12 at%<sup>[11]</sup>, the coatings will exhibit the highest hardness and good oxidation resistance, while the specific threshold content value will vary with different deposition conditions.

The enhancing effect of oxygen element on the properties of Me-N coatings was widely researched <sup>[12,13]</sup>. But the researches about the addition of oxygen element in Me-Si-N coatings were controversial <sup>[14,15]</sup>. Veprek et al. <sup>[14]</sup> believed that oxygen element existed as impurities in TiSiN coatings, and

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the hardness of coatings would decrease significantly with the content of oxygen over 0.5 at%. Nonetheless, some studies indicated that the incorporation of O may promote the properties of Me-Si-N coatings<sup>[15]</sup>.

In our previous research, the non-oxygen TiSiCN, TiCrSiCN and CrSiCN coatings were comparatively studied with respect to their microstructure, adhesion properties and tribological behavior against Ti6Al4V ball<sup>[16]</sup>. The results showed that the TiCrSiCN coating had higher hardness than CrSiCN, better adhesive properties than TiSiCN and lower wear rate against Ti6Al4V than the other two coatings.

In the present paper, oxygen element was added into three metal matrix coatings (Ti-based TiSiCN, Cr-based CrSiCN and TiCr-based TiCrSiCN). The comparative study of microstructure and mechanical properties between non-oxygen and oxygen-containing coatings (TiSiCN vs. TiSiCON, TiCrSiCN vs. TiCrSiCON and CrSiCN vs. CrSiCON) were conducted. The effects of oxygen element on the microstructure, hardness and wear behavior against Al<sub>2</sub>O<sub>3</sub> of these three metal matrix coatings were investigated.

## 1 Experiment

TiSiCN, TiSiCON, TiCrSiCN, TiCrSiCON, CrSiCN and CrSiCON coatings were deposited on K40UF cemented carbide and silicon (100) wafer by plasma enhanced magnetron sputtering (PEMS)<sup>[17]</sup>. The Ar ion sputtering cleaning was conducted before the coating deposition. Then the coatings were produced in a gas mixture of Ar (150 mL/min) and N<sub>2</sub> (50 mL/mim). The substrate bias voltage was set at -40 V. The Si element was introduced by the gas of trimethylsilane ((CH<sub>3</sub>)<sub>3</sub>SiH, TMS). For the O-containing coatings (TiSiCON, TiCrSiCON, CrSiCON), the extra O element was doped by adding hexamethyldisiloxane (HMDSO) vapor. Two targets were employed simultaneously as the source of metal element for each sample. The deposition process was described in previous studies<sup>[16]</sup>. The detailed deposition parameters are shown in Table 1.

The wear loss of the wear tracks were measured by a surface profilometer (AMBIOS XP-2) and then the volume wear rate of coatings were calculated by the conventional formula refer to Li's research<sup>[16]</sup>. The morphology of wear tracks was studied by an optical microscope (Axio Lab.A1,

#### ZEISS, Germany).

Coating phase structure was characterized by X-ray diffraction (Philips X'Pert X) with a Cu K $\alpha$  source and the scanning scope was performed from 20° to 70° at a glancing angle of 2°. The morphology of surface and cross-section was characterized by scanning electron microscopy (SEM) (JEOL JSM-7001F) and the chemical compositions of the coatings were measured with energy dispersive X-ray spectroscopy (EDS). The chemical bonding state of two oxygen-containing coatings TiSiCON and CrSiCON was performed by X-ray photoelectron spectra (XPS) with Al K $\alpha$  radiation (PerkinElmer PHI-5702). The samples was sputtered by Ar ion to eliminate surface contaminants for 100 s.

The coating indentation hardness (*H*) and indentation elastic modulus (*E*) were measured by load-depth-sensing indentation method using an ultra-micro-hardness tester (Shimadzu DUH 211S, Japan) with a Vickers indenter under the maximum indentation load of 100 mN. The indentation elastic modulus was calculated from the slope of the unloading curve which was comparable with the Young's modulus of the material<sup>[18]</sup>. The final values and errors were determined from more than 10 indentations.

The tribological properties (wear and friction) were determined in dry sliding conditions using a pin-on-disc test from a CSEM tribometer (CSEM Instrument, Switzerland) at a load of 5 N and sliding speed of 3 cm/s. Alumina ( $Al_2O_3$ ) balls with 6 mm diameter were employed as the counter materials in wear testing of coatings. The sliding test was conducted for 20 000 laps and the total sliding distance was about 376.8 m.

#### 2 Results

#### 2.1 Surface and cross sectional morphology

Fig.1 and Fig.2 show the surface (the non-oxygen coatings<sup>[16]</sup>) and cross-sectional morphology of these six Ti(Cr)SiC(O)N coatings deposited on Si substrates, respectively. TiSiCN, TiSiCON, TiCrSiCN, TiCrSiCON, CrSiCN coatings exhibit cauliflower-like microstructure<sup>[17]</sup> of the surface, while for the CrSiCON coating, the cauliflowers are more independent with lots of gaps. The cross-sectional morphologies (Fig.2) show that the coating thickness varies from 4~11 µm and declare clearly the columnar growth pattern of all the samples.

Tuble 1 Detailed deposition parameters of six apy countrys of six and countrys								
Coatings	Target 1	Power/kW	Target 2	Power/kW	Gas flow/mL mim <sup>-1</sup>			Time /h
					TMS	HMDSN	HMDSO	- Time/h
TiSiCN	Ti	4	Ti	4		3.5		1.0
TiSiCON	Ti	4	Ti	4			3.5	1.5
TiCrSiCN	Ti	4	Cr	2	7.5	3.4		1.0
TiCrSiCON	Ti	4	Cr	4			3.5	1.5
CrSiCN	Cr	2	Cr	2		3		1.0
CrSiCON	Cr	2	Cr	2			3.5	1.5

Table 1 Detailed deposition parameters of six tapy coatings of six kind coatings

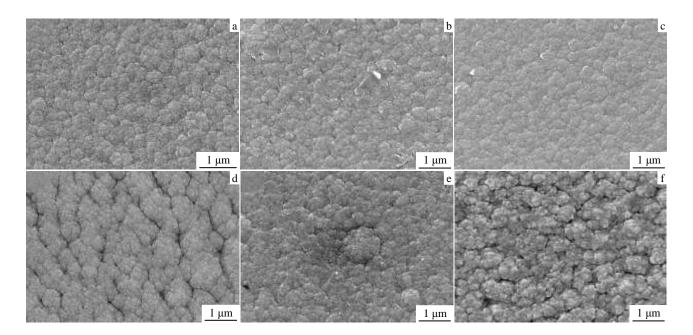


Fig.1 Surface SEM morphologies of the coatings: (a) TiSiCN, (b) TiSiCON, (c) TiCrSiCN, (d) TiCrSiCON, (e) CrSiCN, and (f) CrSiCON

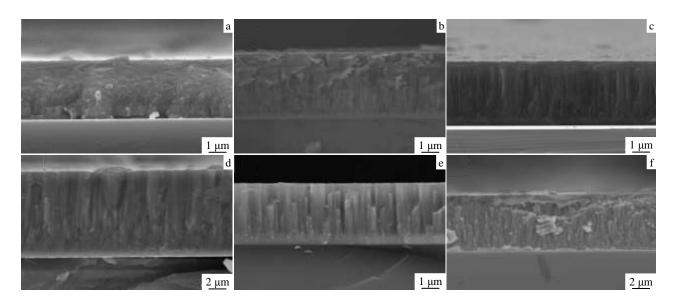


Fig. 2 Cross-sectional SEM morphologies of the coatings: (a) TiSiCN, (b) TiSiCON, (c) TiCrSiCN, (d) TiCrSiCON, (e) CrSiCN, and (f) CrSiCON

Fig. 1 and Fig. 2 also show that the coatings without oxygen (TiSiCN, TiCrSiCN and CrSiCN) exhibit dense surface and cross-sectional morphology compared with the O-containing ones (TiSiCON, TiCrSiCON and CrSiCON). TiCrSiCN and CrSiCN coatings show more pronounced columnar microstructure than TiSiCN coating nearly throughout the entire thickness of the coating. The O-containing coating (TiCrSiCON and CrSiCON) surfaces show more obvious grain boundaries than the oxygen-free ones, and the defects between columnar crystals increase dramatically. Especially for the CrSiCON, the coating surface shows the most apparent

defects at the grain boundary with large vacant position, compared with Ti-based TiSiCON and TiCr-based TiCrSiCON coatings.

## 2.2 Phase compositions

X-ray diffraction patterns of the coatings on Si(100) substrate are shown in Fig.3 and the chemical composition of Ti(Cr)SiC(O)N coatings is shown in Table 2. The diffraction peaks of TiSiCN and TiSiCON coatings are corresponding to face-centered cubic (fcc) Ti(C)N, without apparent orientation. TiCrSiCN coating exhibits the combination of fcc  $Cr(C)N^{[19]}$  and Ti(C)N phase.

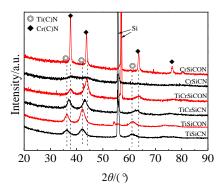


Fig. 3 XRD patterns of Ti(Cr)SiC(O)N coatings on Si(100) substrate

 Table 2
 Chemical composition of Ti(Cr)SiC(O)N coatings (at%)

Coatings	Ti	Cr	Si	Others(C, N, O)
TiSiCN	41.48	-	11.89	46.63
TiSiCON	39.31	-	7.17	53.52
TiCrSiCN	20.13	23.62	11.44	44.81
TiCrSiCON	11.36	52.14	4.09	32.41
CrSiCN	-	48.56	11.56	39.88
CrSiCON	-	49.55	5.96	44.49

While TiCrSiCON coating consists mostly of Cr(C)N phase, which is owing to the abundance of chromium in TiCrSiCON coating (Table 2). CrSiCN coating shows fairly weak peaks of Cr(C)N phase, which indicate large amorphous phase in CrSiCN. CrSiCON coating shows a typical fcc CrN structure with narrow peaks compared with CrSiCN coating. In XRD results, there do not show any crystalline siliconcontaining phase, and this is similar to other literatures<sup>[20,21]</sup>. The XRD results show that no oxide crystals can be found, which indicates that the oxygen probably most exists in amorphous phase in the grain boundaries.

#### 2.3 Mechanical properties

Fig.4 shows the hardness (H) and elastic modulus (E) of these Ti(Cr)SiC(O)N coatings. The coatings without oxygen exhibit higher hardness than the O-containing coatings (TiSiCN vs TiSiCON, TiCrSiCN vs TiCrSiCON, CrSiCN vs CrSiCON). For the TiSiCN and CrSiCN coatings, the addition of oxygen even decreases the hardness by more than half, which indicates that the existence of oxygen decreases the hardness significantly. Ti-based TiSiCN coating shows the maximum hardness of appropriately 25 GPa, while the maximum elastic modulus appears in Cr-based CrSiCN coating of 285 GPa. CrSiCON coating shows the minimum hardness of about 12.5 GPa and a small elastic modulus of 196 GPa. The minimum elastic modulus appears in TiSiCON of 186 GPa. Therefore, we can conclude that the Ti-based coating shows higher hardness and lower elastic modulus (TiSiCN vs CrSiCN, TiSiCON vs CrSiCON).

## 2.4 Tribological properties and wear behavior

The tribological properties of the Ti(Cr)SiC(O)N coatings are

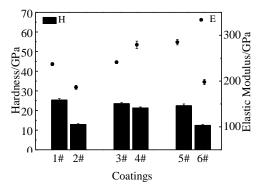


Fig.4 Hardness and elastic modulus of Ti(Cr)SiC(O)N coatings (1#-TiSiCN, 2#-TiSiCON, 3#-TiCrSiCN, 4#-TiCrSiCON, 5#-CrSiCN, and 6#-CrSiCON)

Table 3	Elastic recovery (W <sub>e</sub> ) of Ti(Cr)SiC(O)N coatings,			
	friction coefficient and wear rate against Al <sub>2</sub> O <sub>3</sub> balls			

Coatings         Friction coefficient         Wear rate/ $\times 10^{-7}$ mm <sup>3</sup> N <sup>-1</sup> m           TiSiCN         0.21         15.30           TiSiCON         0.30         32.90           TiCrSiCN         0.67         29.06           TiCrSiCON         0.54         9.89           CrSiCN         0.42         13.50           CrSiCON         0.38         5.34			8 2-3
TiSiCON0.3032.90TiCrSiCN0.6729.06TiCrSiCON0.549.89CrSiCN0.4213.50	Coatings	Friction coefficient	Wear rate/ $\times 10^{-7}$ mm <sup>3</sup> N <sup>-1</sup> m <sup>-1</sup>
TiCrSiCN         0.67         29.06           TiCrSiCON         0.54         9.89           CrSiCN         0.42         13.50	TiSiCN	0.21	15.30
TiCrSiCON         0.54         9.89           CrSiCN         0.42         13.50	TiSiCON	0.30	32.90
CrSiCN 0.42 13.50	TiCrSiCN	0.67	29.06
	TiCrSiCON	0.54	9.89
CrSiCON 0.38 5.34	CrSiCN	0.42	13.50
	CrSiCON	0.38	5.34

researched by the pin-on-disc wear test. The typical optical morphology of the wear track and profile on the Ti(Cr)SiC(O)N coatings were studied by OM and surface profilometer. All the morphologies show apparent abrasion wear grooves, indicating that the wear mechanism for six coatings against  $Al_2O_3$  is abrasive wear. The wear rates shown in Table 3 were calculated by integrating the profile of the wear track. When comparing all the six Ti(Cr)SiC(O)N coatings, there is no simple correlation between the wear rates and the friction coefficients. But between the same metal matrix coatings, the values of wear rate inversely correlation with the friction coefficients (TiSiCN vs. TiSiCON, TiCrSiCN vs. TiCrSiCON and CrSiCN vs. CrSiCON). For the Ti-based coating, the wear rate of TiSiCON exhibits 2 times more than that of TiSiCN. The existence of oxygen decreases the abrasive resistance remarkably in Ti-based TiSiCN coating. However, for the TiCr-based and Cr-based coatings, the addition of oxygen reduces the friction coefficients and the wear rates of coatings significantly. The wear rate of TiCrSiCN is 3 times larger than that of TiCrSiCON. The wear rate of CrSiCN is about 2.5 times more than that of the CrSiCON.

#### 3 Discussion

In this part, the effect of oxygen on the structure and mechanical properties of coatings will be discussed. The surface morphology of O-containing coatings (TiCrSiCON and CrSiCON) shows a porous feature with apparent defects (shown in Fig. 1d and Fig. 1f) and cross sectional structure with cracked and irregular columnar (shown in Fig. 2d and Fig.2f). Emmerlich et al.<sup>[22]</sup> have found that O is likely to react with Si and form Si-O gaseous species during the diffusion of oxygen into the film. In the deposition process, the Si-O evaporation is likely to occur and leave these vacant positions at the grain boundaries. And indeed, the chemical compositions of Ti(Cr)SiC(O)N coatings (shown in Table 2) demonstrate that the O-containing coatings contain less silicon contents than O-free coatings.

Moreover, the oxygen which exists in coatings plays an important role on the 'nanocomposite' microstructure. The silicon in Me-Si-N coatings (without oxygen) always appears to be amorphous  $Si_3N_4$  phase in the grain boundaries. The existence of a certain amount of silicon could increase the amorphous phase and reduce grain coarsening in TiSiCN coating<sup>[23,24]</sup>.

While, the addition of oxygen would prevent this refining process by reducing the amount of  $Si_3N_4$ , possibly because of the electronic effect, the strong electron affinity of oxygen is probably to weaken the Si–N bonds, and forming silicon oxynitride (Si-O-N) or other oxide in the gain boundaries with lower hardness than  $Si_3N_4$ <sup>[25]</sup>.

Thus, the adverse influence of oxygen on microstructure of coatings is likely to destroy the structure of nanocomposite nc-MeN/a-Si<sub>3</sub>N<sub>4</sub> and form porous grain boundaries with oxides. So the hardness of O-containing coatings (TiSiCON, TiCrSiCON and CrSiCON) was decreased obviously. Actually, for the O-containing coatings, the oxidation of Ti element (or Cr) cannot be ignored during the growth of coatings. The oxidation of different atoms at the high-temperature could be used as reference. Ti atoms oxidized rapidly to semi-protective TiO<sub>2</sub>, while Si usually oxidized to the extremely protective SiO<sub>2</sub> with low diffusivity for both anions and cations. The phenomenon that TiO<sub>2</sub> grew at more accelerated rate than the SiO<sub>2</sub> in the process of oxidation was also found in other study<sup>[26]</sup>. While the formation of SiO<sub>2</sub> was easier and earlier than Cr<sub>2</sub>O<sub>3</sub> with the increasing of oxygen during the growth of films<sup>[27]</sup></sup>. For these reasons, it can be speculated that the TiO<sub>2</sub> would be more than the amount of SiO<sub>2</sub> in TiSiCON coating. While for the TiCrSiCON and CrSiCON coatings with noble Cr, the reactively active Si probably formed more SiO<sub>2</sub>. In order to clarify the existing state of oxides phase in the oxygen-containing coatings, the high resolution XPS spectra of O and Si elements for two TiSiCON and CrSiCON coatings were studied. The results showed more SiO<sub>2</sub> in CrSiCON coating. And it has been proved that SiO<sub>2</sub> phase can act as lubricant in the friction process [28]. Therefore, for the O-containing TiCrSiCON and CrSiCON coatings, probably because the more SiO<sub>2</sub> phase acts as lubricant, the friction coefficient and wear rate significantly decline to a small value than TiCrSiCN and CrSiCN, respectively. While for the Ti-based TiSiCON coating, both the friction coefficient and

the wear rate are higher than that of TiSiCN coating. Probably without enough lubricant  $SiO_2$  phase, drawback of the loose structure and cracked columnar crystal of TiSiCON coating become the main influence factors in friction and wear.

#### 4 Conclusions

1) TISICN, TISICON, TICRSICN, TICRSICON, CrSICN and CrSICON coatings are deposited on WC-Co substrates and Si wafers by PEMS technique.

2) The existence of oxygen would induce loose surface structure for TiSiCON, TiCrSiCON and CrSiCON coatings, which is likely ascribed to the evaporation of Si-O gaseous species in deposition process. And oxygen in the grain boundaries would hinder the refining grain effect of Si element and create more defects, through forming Si-O-N (or Si-O) bond.

3) The oxygen-containing TiSiCON, TiCrSiCON and CrSiCON coatings still exhibit a face center cubic (fcc) TiN-type (CrN-type) structure. The addition of oxygen element would decrease the hardness and elasticity of coatings. The addition of oxygen would form amorphous oxygen compounds SiO<sub>2</sub>, which could act as lubricant for TiCr-based TiCrSiCON and Cr-based CrSiCON coatings during friction and wear, and reduce the friction coefficient and wear rate when compared with TiCrSiCN and CrSiCN, respectively. But, for Ti-based TiSiON coating, the wear rate increases significantly probably because of fewer lubricant SiO<sub>2</sub> oxides and the loose structure. **Acknowledgements:** The authors would like to thank Prof. R.H. Wei (Southwest Research Institute, San Antonio, USA) for his technical assistance on fabricating coating.

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## 等离子体增强磁控溅射制备 Ti(Cr)SiC(O)N 涂层的结构和力学性能研究

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摘 要:采用等离子体增强磁控溅射(PEMS)方法分别在硬质合金和硅片上制备了 TiSiCN, TiSiCON, TiCrSiCN, TiCrSiCON, CrSiCN 和 CrSiCON 涂层。采用 XRD、SEM、EDS、显微硬度计及销盘式摩擦磨损试验机对含氧涂层和不含氧涂层的微观结构、成分和力学性能 进行了研究。结果表明,TiSiCON,TiCrSiCON 和 CrSiCON 含氧涂层为 TiN 型(或 CrN 型)面心立方(fcc)结构,但是 TiSiCON,TiCrSiCON 和 CrSiCON 涂层中氧的存在会导致产生疏松结构,与不含氧涂层 TiSiCN, TiCrSiCN 和 CrSiCN 相比具有更多的缺陷;氧的加入会导致 Ti(Cr)SiCN 涂层硬度和弹性的下降;TiCrSiCON 和 CrSiCON 2 种含氧涂层相对于不含氧涂层 TiCrSiCN 和 CrSiCN 具有更低的摩擦系数 和磨损率;然而,TiSiCON 相对于 TiSiCN 却表现出更高的摩擦系数和磨损率。

关键词: Ti(Cr)SiC(O)N; 含氧涂层; 微观结构; 硬度; 磨损

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